

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of

Attorney Docket No. 2006 1016A

Shinji KAJITA et al.

Mail Stop: PCT

Serial No. 10/585,482

Filed July 10, 2006

SUBSTRATE PROCESSING
APPARATUS AND METHOD
[Corresponding to PCT/JP2005/003423
Filed February 23, 2005]

## **REQUEST FOR NOTICE OF ACCEPTANCE**

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

We have not yet received a Notice of Acceptance in the above-referenced application. Issuance of a Notice of Acceptance is respectfully requested.

Respectfully submitted,

Shinji KAJITA et al.

By:

THE COMMISSIONER IS AUTHOUSE TO CHARGE ANY DEFICIENCY:
FEES FOR THIS PAPER TO DEPOSE ACCOUNT NO. 23-0975

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